PTO-1449

Application No. 09/976,723

Applicant(s)
Niels F. Jacksen, et al

Formation Disclosure Citation
On Application

Docket Number 019937.0395 (ET 00-07) Group Art Unit 2811 Filing Date 2002 October 11, 2001

## **U.S. PATENT DOCUMENTS**

NEW .	S TVX	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
ئىرى	Δ	4,472,239	09/18/84	Johnson, et al	156	647	07/08/83
1	В	4,478,076	10/23/84	Bohrer	73	204	09/30/82
	С	4,478,077	10/23/84	Bohrer, et al	73	204	09/30/82
$\parallel$	D	4,501,144	02/26/85	Higashi, et al	73	204	09/30/82
	Е	4,624,137	11/25/86	Johnson, et al	73	204	10/01/85
1	F	4,682,503	07/28/87	Higashi, et al	73	755	05/16/86
1	G	4,683,159	07/28/87	Bohrer, et al	428	138	06/17/86
	Н	4,696,188	09/29/87	Higashi	73	204	09/06/85
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$\exists$	J	4,825,693	05/02/89	Bohrer, et al	73	204.25	10/20/86
1	K	4,867,842	09/19/89	Bohrer, et al	156	. 647	05/16/88
1	L	4,914,742	04/03/90	Higashi, et al	357	26	12/07/87
T	M	4,966,037	10/30/90	Sumner, et al	73	204.26	10/01/85
Silv	N	5,220,188	06/15/93	Higashi, et al	257	467	07/06/83

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w	Q,	Breen, Thomas, et al, "More Applications of Uncooled Microbolometer Sensors", Part of the SPIE Conference on Infrared Technology and Applications XXIV, San Diego, CA, SPIE Vol. 3436, pp. 530-540	July 1998
w	R 1	Kreider, James F., et al, "Multiplexed mid-wavelength IR long, linear photoconductive focal plane arrays", SPIE Vol. 1488 Infrared Imaging Systems: Design, Analysis, Modeling, and Testing II, pp. 376-388	1991
w	S /	Radford, W., et al, "Microbolometer Uncooled Infrared Camera with 20 mK NETD*", Part of the SPIE Conference on Infrared Technology and Applications XXIV, San Diego, CA, SPIE Vol. 3436, pp. 636-646	July 1998
w	Т /	Jhabvala, Murzban D., et al, "A Monolithic Lead Sulfide-Silicon MOS Integrated-Circuit Structure", IEEE Transactions on Electron Devices, Vol. ED-29, No. 12, pp. 1900-1905	December 1982

**EXAMINER** 

DATE CONSIDERED

7-11-2003

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

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w	U	5,220,189	06/15/93	Higashi, et al	257	467	07/06/83
	V	5,286,976	02/15/94	Cole	250	349	11/07/88
	W	5,300,915	04/05/94	Higashi, et al	338	22 R	07/16/86
	X	RE 36,136	03/09/99	Higashi, et al	338	18	04/04/96
	Y	5,420,419	05/30/95	Wood	250	338.4	02/28/94
	Z	5,450,053	09/12/95	Wood	338	18	06/29/93
	AA	5,534,111	07/09/96	Hocker, et al	216	15	02/29/88
w	ВВ	5,561,295	10/01/96	Jacksen, et al	250	338.4	07/29/94
	CC						
	DD						
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		DOCUMENT (Including Author, Title, Source, and Pertinent Pages)	DATE
ir.	кк /	U.S. Patent Appln. Serial No. 09/976,191 filed October 11, 2001, entitled "Hybridized Lead-Salt Infrared Radiation Detectors and Methods of Formation", inventors Niels F. Jacksen, et al, 34 pages of Specification, Abstract and Claims, and 7 pages of drawings	10/11/2001
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